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	Application No.	Applicant(s)		
	10/750,819	INAGAWA ET AL.		
Notice of Allowability	Examiner	Art Unit		
	Andy Huynh	2818		
The MAILING DATE of this communication appeal claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIP of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this app or other appropriate communication IGHTS. This application is subject to	olication. If not include will be mailed in due	ed course. THIS	
1. X This communication is responsive to the Preliminary Amen	ndments dated 01/05/04 and 01/15/0	<u>4</u> .		
2. \boxtimes The allowed claim(s) is/are <u>8-19</u> .				
3. $igotimes$ The drawings filed on <u>05 January 2004</u> are accepted by the	e Examiner.			
4. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give	e been received. e been received in Application No. 10 cuments have been received in this of this communication to file a reply dENT of this application. eitted. Note the attached EXAMINER des reason(s) why the oath or declaration.	national stage applica complying with the red	quirements	
6. CORRECTED DRAWINGS (as "replacement sheets") mus		048) -#		
(a) ☐ including changes required by the Notice of Draftspers		946) attached		
1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Identifying Indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the state of the sheet in the state of the sheet.	s Amendment / Comment or in the C .84(c)) should be written on the drawin	ngs in the front (not the	back) of	
7. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT	sit of BIOLOGICAL MATERIAL n	nust be submitted.	Note the	
Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 01/05/04 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	5. ☐ Notice of Informal P 6. ☐ Interview Summary Paper No./Mail Dat 7. ☑ Examiner's Amendn 8. ☑ Examiner's Stateme 9. ☐ Other David Nelms	(PTO-413), lenent/Comment	·	
Supervisory Patent Examiner Technology Center 2800				

DETAILED ACTION

In the Preliminary Amendment dated January 5, 2004, Applicant has canceled claims 2-7 without prejudice or disclaimer, and in the Second Preliminary Amendment dated January 15, 2004, Applicant has also canceled claim 1 without prejudice or disclaimer, and added new claims 8-19 is acknowledged. Accordingly, claims 1-7 are canceled and claims 8-19 are currently pending in the application. This application is continuation of Application No. 10/104,012 filed 03/25/2002, USP 6,706,604, which is a divisional of Application Serial No. 09/604,917 filed 06/28/2000, now abandoned.

Examiner's Amendment

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows:

In claim 8, page 3, line 3, "the fate" is changed to -the gate--.

Allowable Subject Matter

Claims 8-19 are allowed.

The following is an examiner's statement of reason for allowance: The prior art of record fails to teach or suggest the limitation recited a semiconductor device having a MISFET in a first

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region of a semiconductor substrate and a gate wiring in a second region of the semiconductor substrate comprises an insulating film is formed in the second region, and the gate wiring outside the second trench is formed on the insulating film as recited in independent claims 8 and 18.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance".

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Andy Huynh whose telephone number is (571) 272-1781. The examiner can normally be reached on Monday-Friday 8:30am-5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571) 272-1787. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 872-9306 for regular communications and (703) 872-9306 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

ΑH

David Nelms
Supervisory Patent Examiner
Technology Center 2800

06/24/04